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APPLICANTS

Takeshi Fukunaga, Kanagawa, JAPAN;

** CONTINUING DATA **

This application is a DIV of 09/907,911 07/19/2001 PAT 6,602,761
 which is a DIV of 09/356,704 07/20/1999 PAT 6,271,101

9VB

** FOREIGN APPLICATIONS **

JAPAN 10-214125 07/29/1998

9VB

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 10/30/2003

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY JAPAN	SHEETS DRAWING 7	TOTAL CLAIMS 39	INDEPENDENT CLAIMS 8
Verified and Acknowledged	Examiner's Signature: <i>William M. Bremley</i> Initials:				

ADDRESS

22204
 NIXON PEABODY, LLP
 401 9TH STREET, NW
 SUITE 900
 WASHINGTON, DC
 20004-2128

TITLE

Process for production of SOI substrate and process for production of semiconductor device

FILING FEE

FEES: Authority has been given in Paper
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